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Date

Signature *Rebecca Ginn*

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
Cem Basceri, et al.

Serial No.: 10/762,706

Filed: 1/22/2004

For: Micromachines for Delivering  
Precursors and Gases  
for Film Deposition

Group Art Unit: 1763

Examiner: unk

Atty. Dkt. No.: 102-0075US2

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria VA, 22313-1450

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement (IDS) be entered and the documents listed on attached Form PTO-1449 be considered by the Examiner and made of record. Copies of the listed documents are attached.

In accordance with 37 C.F.R §§ 1.97(g),(h), this IDS is not to be construed as a representation that a search has been made, and is not to be construed to be an admission that the information cited is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b), or that such information constitutes prior art.

This IDS is being filed before receipt of a first office action on the merits. Accordingly, no fee is believed due pursuant to 37 C.F.R. § 1.97(b). However, should any fees be due, the

PTO is authorized to deduct any necessary fees from Deposit Account No. 501922, referencing matter no. 102-0075US2.

Applicant respectfully requests that the listed documents be considered and made of record in the present case, and that the Examiner initial the appropriate spaces on the Form 1449 to evidence the same

Respectfully submitted,



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Nov. 12, 2004



Form PTO-1449 (modified)

Atty. Docket No.  
102-0075US2Serial No.  
10/762,706

## List of Patents and Publications for Applicant's

Applicant / Inventor

Micron Technology, Inc., / Cem Basceri et al.

## INFORMATION DISCLOSURE STATEMENT

Filing Date:  
1/22/2004Group:  
1763

(Use several sheets if necessary)

## U.S. Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Name	Class	Sub Class	Filing Date of App.
	A1	5082517	01-1992	Moslehi	156	345.26	
	A2	6176930	01-2001	Koai et al.	118	715	
	A3	6548112	04-2003	Hillman et al.	427	248.1	11/18/1999
	A4	5911834	06-1999	Fairbairn et al.	134	1.3	
	A5	5876503	03-1999	Roeder et al.	118	715	
	A6	4934401	06-1990	Ikehata et al.	137	82	
	A7						

## Foreign Patent Documents

Exam. Init.	Ref. Des.	Document Number	Date	Country	Class	Sub Class	Translation Yes/No
	B1						

## Other Art (Including Author, Title, Date Pertinent Pages, Etc.)

Exam. Init.	Ref. Des.	Citation
	C1	

EXAMINER:

DATE CONSIDERED:

EXAMINER: INITIAL IF REFERENCE CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED. INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.

INFORMATION DISCLOSURE STATEMENT — PTO-1449 (MODIFIED)

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